



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of : **Confirmation No. 5731**
Akihisa HONGO et al. : Attorney Docket No. 2001_0133A
Serial No. 09/762,582 : Group Art Unit 1753
Filed April 12, 2001 : Examiner Arun Phasge
SUBSTRATE PLATING
METHOD AND APPARATUS : **Mail Stop: Amendment**

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of June 10, 2005, the period for response to which having been extended by two months to November 10, 2005, please amend the above-identified U.S. Patent application as follows: